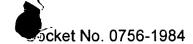
JUN 1 3 2003 -1-



IN THE LINE STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)	Art Unit: 2811
Shunpei YAMAZAKI et al.)	Examiner: S. Hu
Serial No. 09/334,646)	CERTIFICATE OF MAILING
Filed:	June 17, 1999)	I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 11, 2003.
For:	SEMICONDUCTOR DEVICE AND	D)	
	FABRICATION METHOD)	
	THEREOF)	

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 11, 2003, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend the claims as follows:

106. (Amended) The display device according to claim 104, wherein the laser annealing is performed to crystallize an amorphous semiconductor layer in order to obtain a crystalline semiconductor layer.

109. (Amended) The display device according to claim 107, wherein the laser annealing is performed to crystallize an amorphous semiconductor layer in order to obtain a crystalline semiconductor layer.